



# Stress Testing of Semiconductor Switches for PV Inverter Applications at Sandia National Laboratories

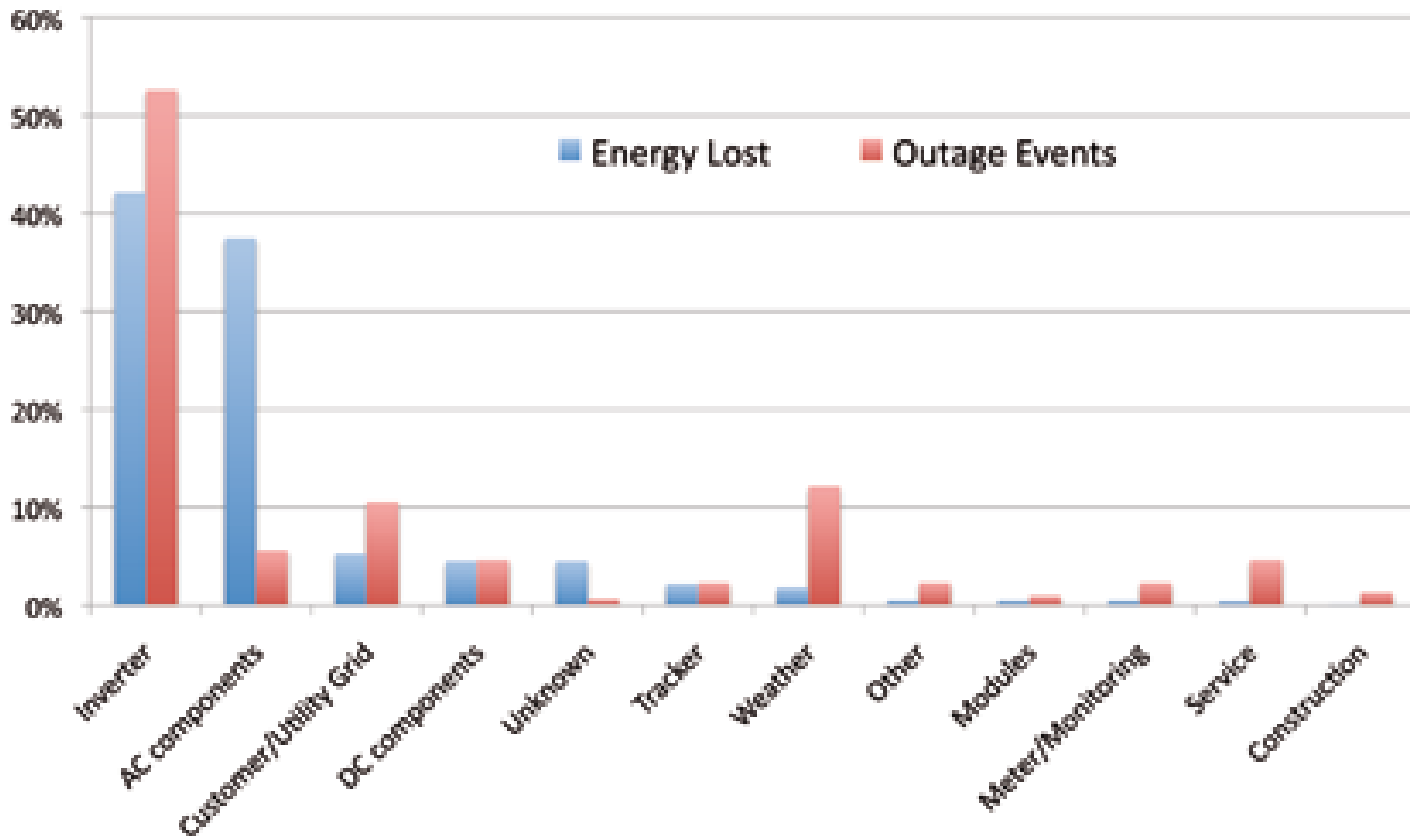
## Utility-Scale Grid-Tied PV Inverter Reliability Workshop

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January 27, 2011

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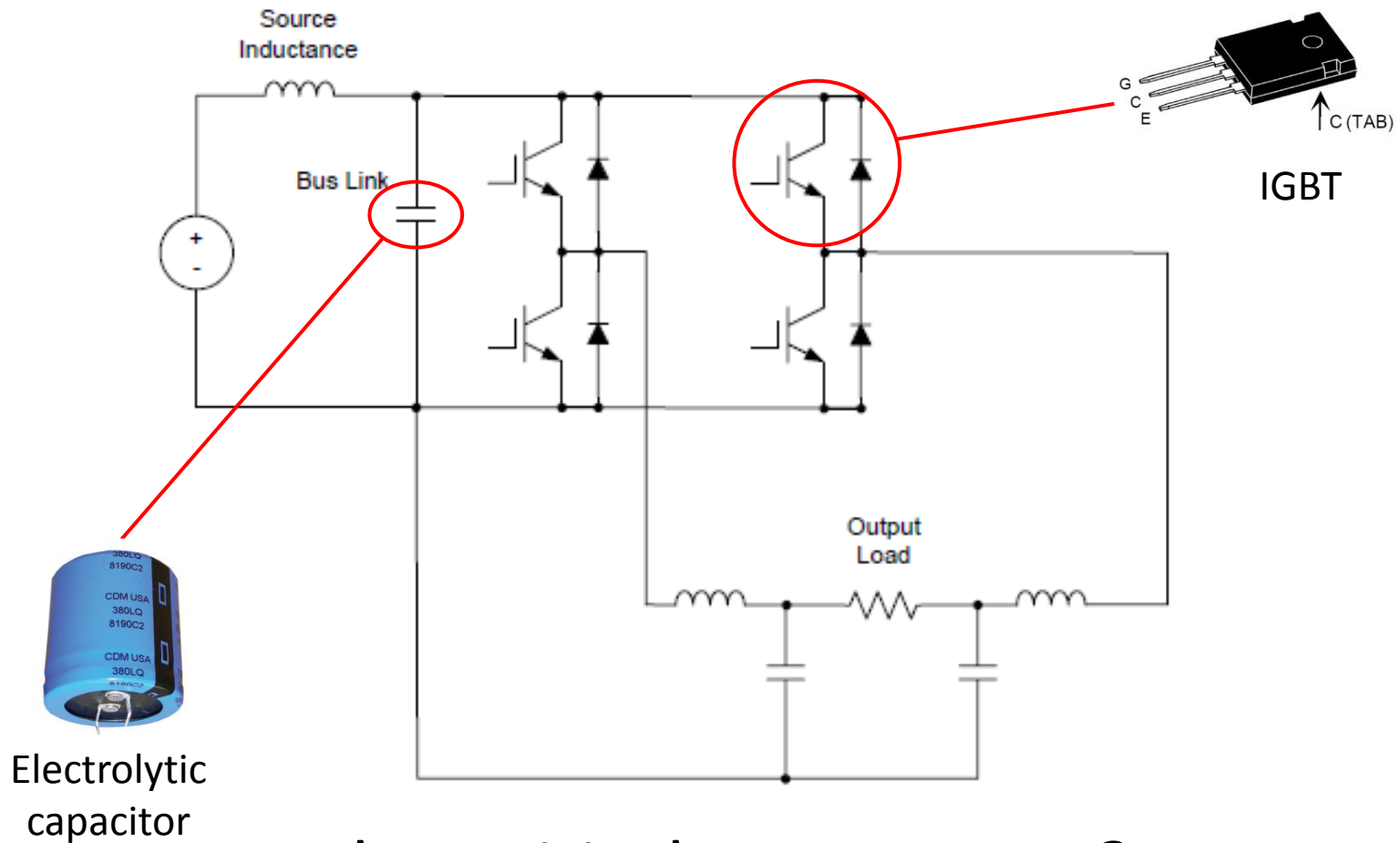
This work was performed under funding from the DOE Solar Energy Technologies Program and the DOE Office of Electricity Energy Program.

# Is the inverter the least reliable component of the PV system?



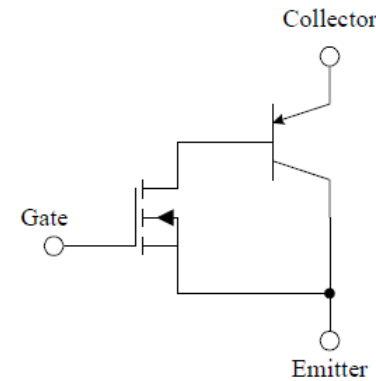
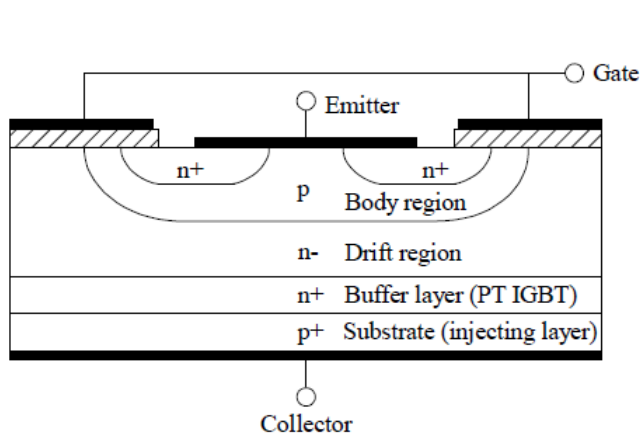
Source: Photovoltaics International pp. 173-179  
PV International Edition 5 (Sep. 16, 2009)

# Basic inverter circuit topology (single-phase H-bridge)

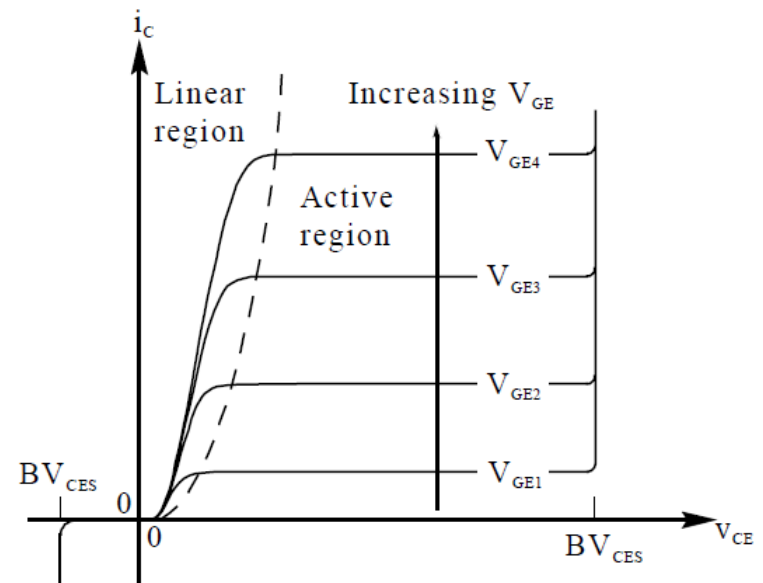


Other critical components?

# Semiconductor switch: Insulated-Gate Bipolar Transistor (IGBT)



- Hybrid MOS-bipolar structure
- Main conduction is through the bipolar device with the base current controlled by the MOS device
- Allows for very high collector currents coupled with high gate impedance
- Switching tends to be slower than power MOSFET due to minority carrier storage in base region
- Unlike power MOSFET, minimal reverse current



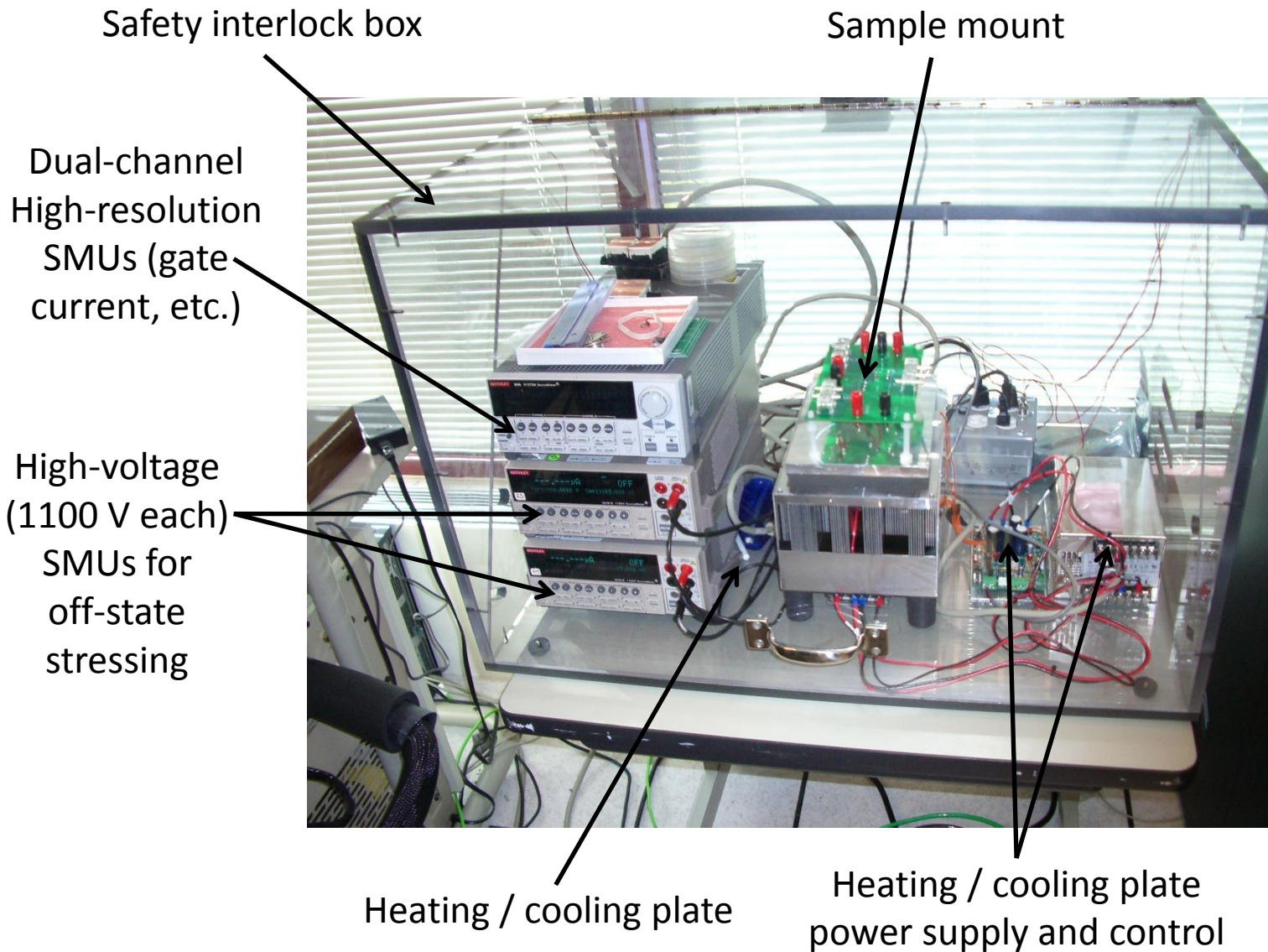
Drawings from Advanced Power Technology Application Note APT0201 (July 2002)



# IGBT Device Reliability

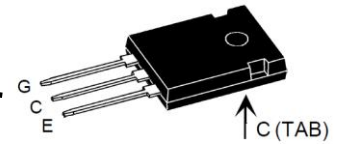
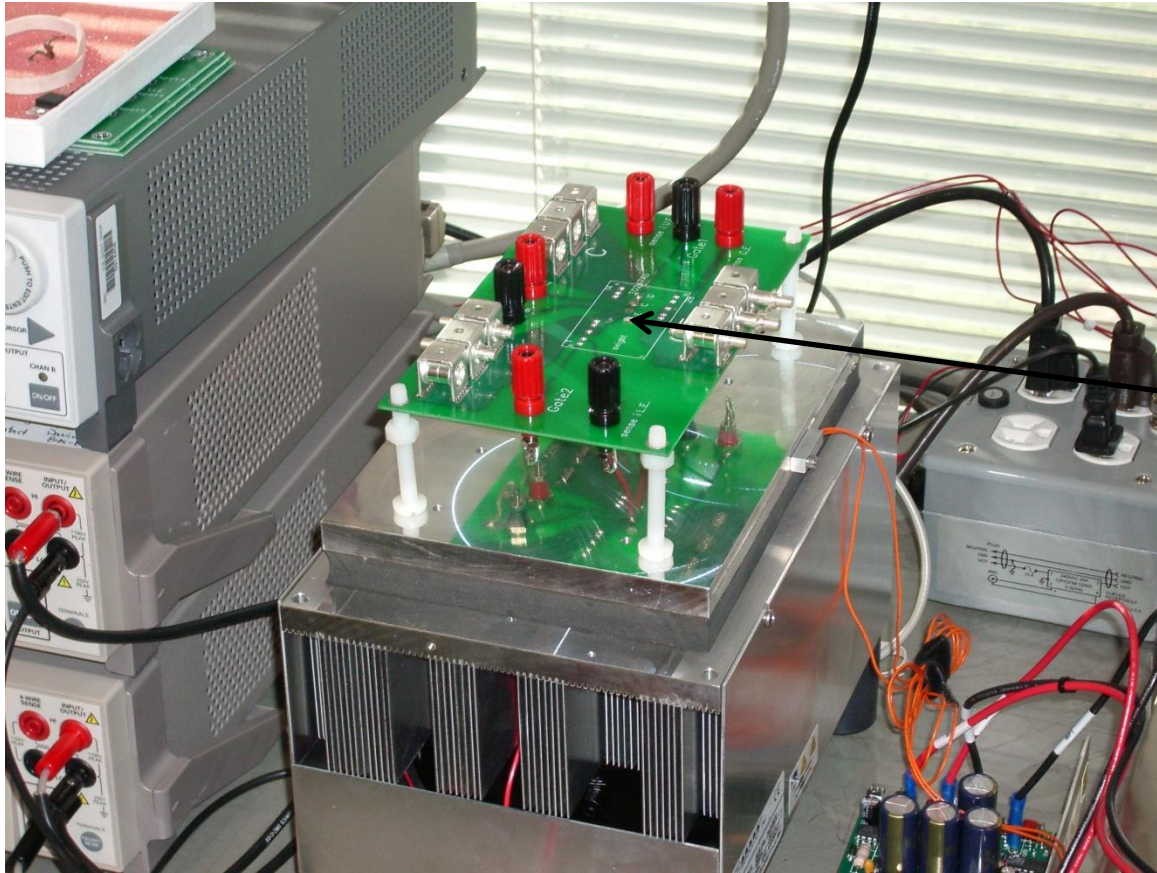
- IGBT is repeatedly subjected to alternating cycles of ON state (high current / low voltage) and OFF state (low current / high voltage)
- During switching, the device is briefly (few  $\mu\text{s}$ ) subjected to a transition during which it experiences very high power (high current / high voltage)
- High power generates lots of heat; improper heat-sinking may degrade device lifetime and / or cause catastrophic failure
- Inverter may need to operate in hot environments, and may also be subject to wide swings in operating temperature
- Si- based IGBT is a fairly mature but is subject to degradation mechanisms that are common to all Si-based devices (e.g.  $\text{SiO}_2$  gate breakdown)
- Our initial testing has been focused on high current / low voltage stress condition

# Experimental set-up





# Sample mounting

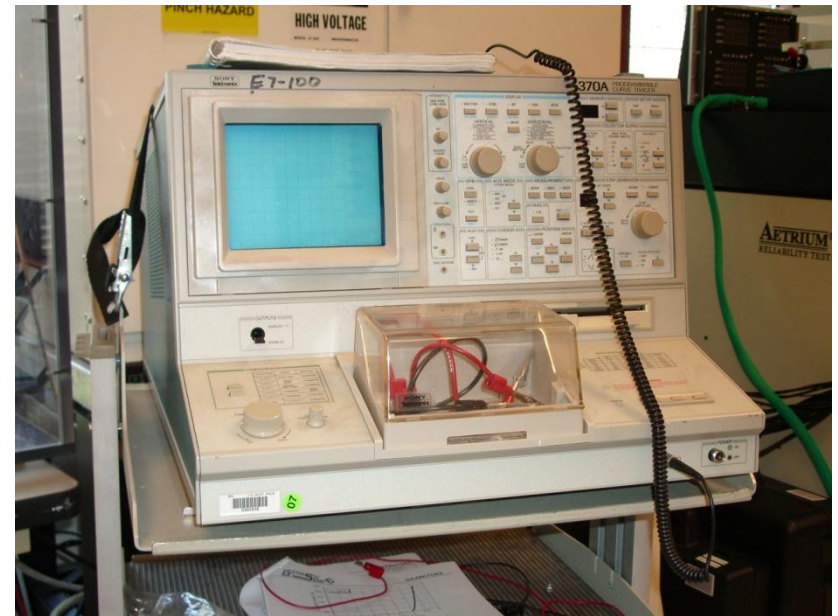


# Stress / measure equipment



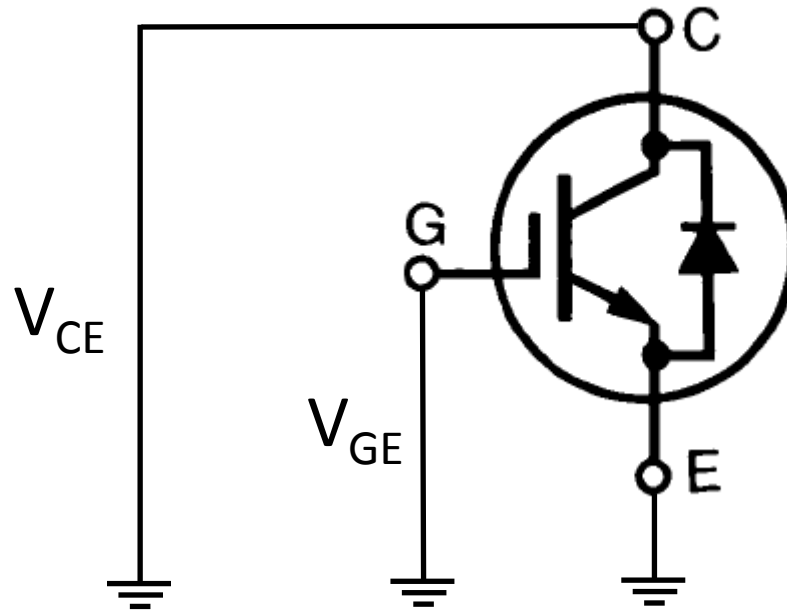
3200 W power supply  
(400 A, 8 V)

Curve tracer

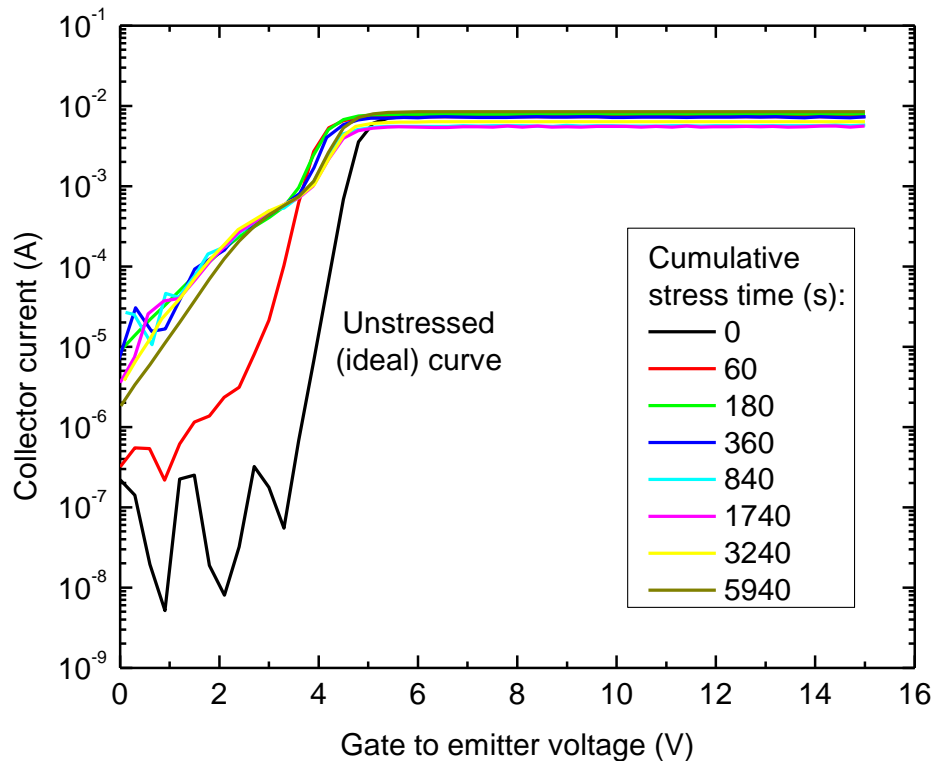




# Bias configuration for IGBT stress-measure experiments



# Experiment #1 (25°C stress)



600 V, 60 A device  
found in several inverters  
that we examined

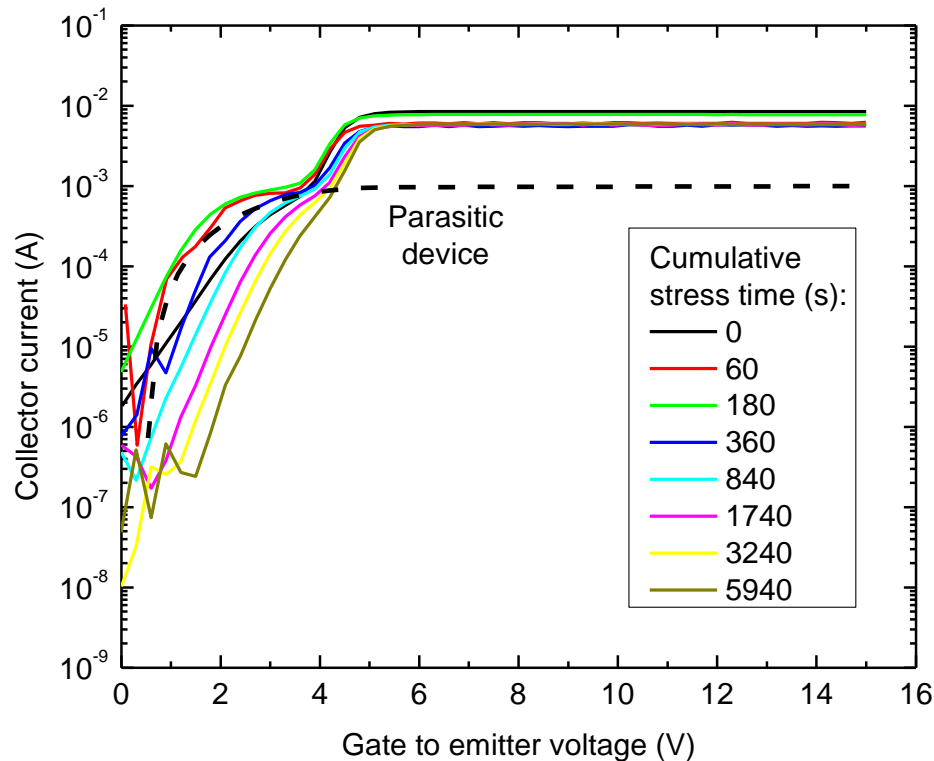
Fast initial degradation in  
sub-threshold region,  
appears to saturate;  
not much degradation in  
on-state characteristics

Degradation not observed  
on all samples tested (a few  
samples measured so far)

1. Measure  $I_C$ - $V_{GE}$  curve for fixed  $V_{CE} = 1$  V at 25°C
2. Stress device using  $V_{GE} = 20$  V,  $V_{CE} = 2$  V at 25°C;  $I_C \approx 38$  A
3. Repeat

# Experiment #2 (100°C stress)

Use the same device as the previous experiment



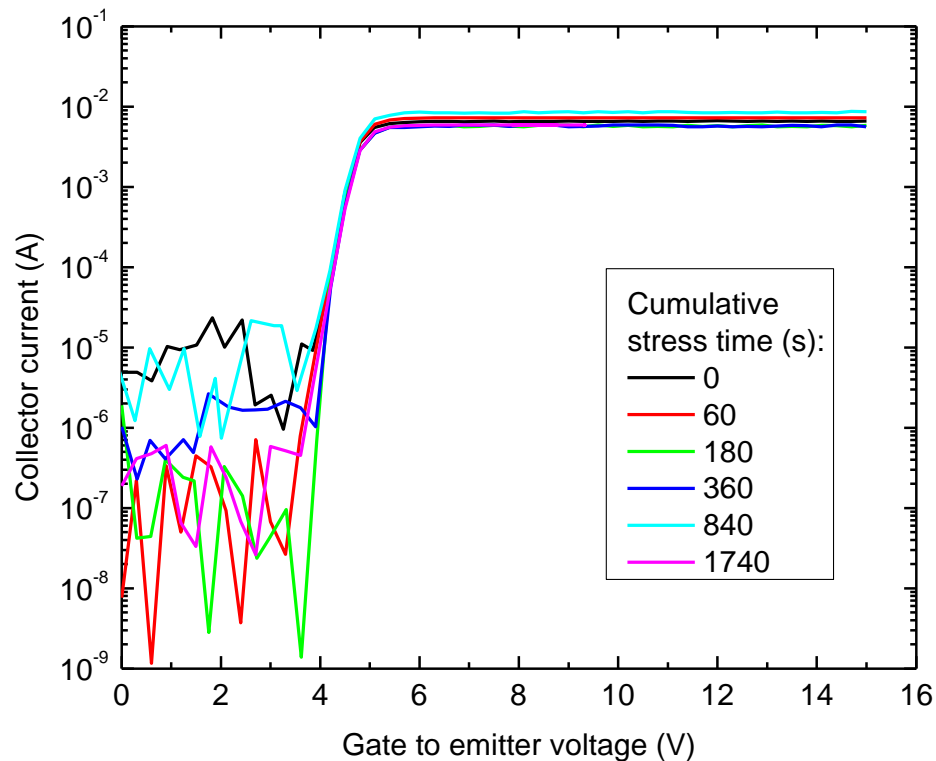
High-temperature stress appears to anneal out the damage from the low-temperature stress

Is change in IV curve due to introduction of parasitic device?

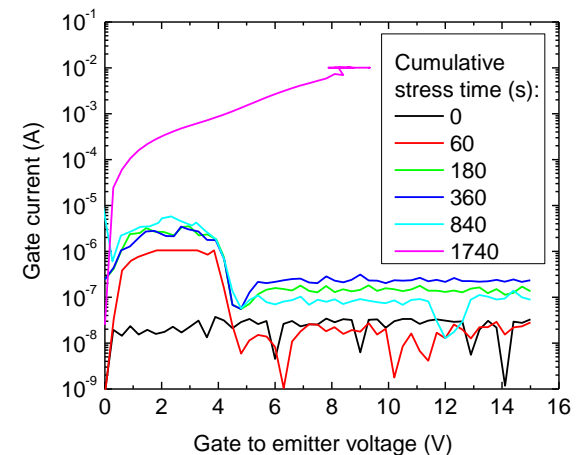
1. Measure  $I_C$ - $V_{GE}$  curve for fixed  $V_{CE} = 1$  V at 25°C
2. Stress device using  $V_{GE} = 20$  V,  $V_{CE} = 2$  V at 100°C;  $I_C \approx 38$  A
3. Repeat

# Experiment #3 (100°C stress)

Use a fresh device

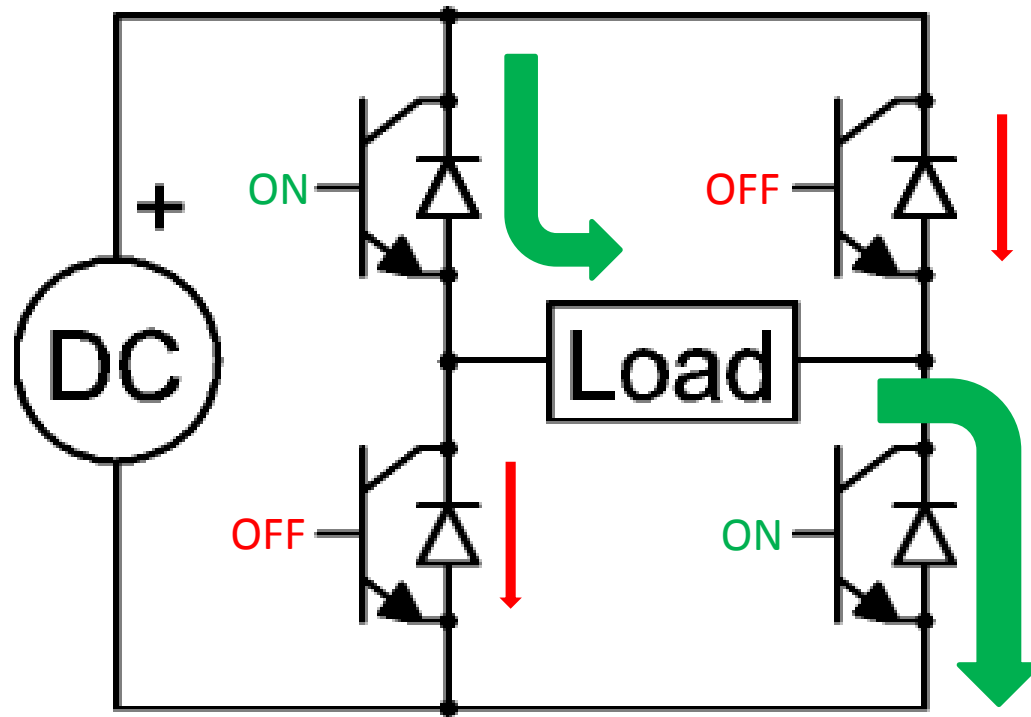


Minimal degradation when stressed at high temperature; results suggestive of hot-carrier damage in the MOS part of the device; but gate current becomes worse at high T (different failure mechanism)



1. Measure  $I_C$ - $V_{GE}$  curve for fixed  $V_{CE} = 1$  V at 25°C
2. Stress device using  $V_{GE} = 20$  V,  $V_{CE} = 2$  V at 100°C;  $I_C \approx 38$  A
3. Repeat

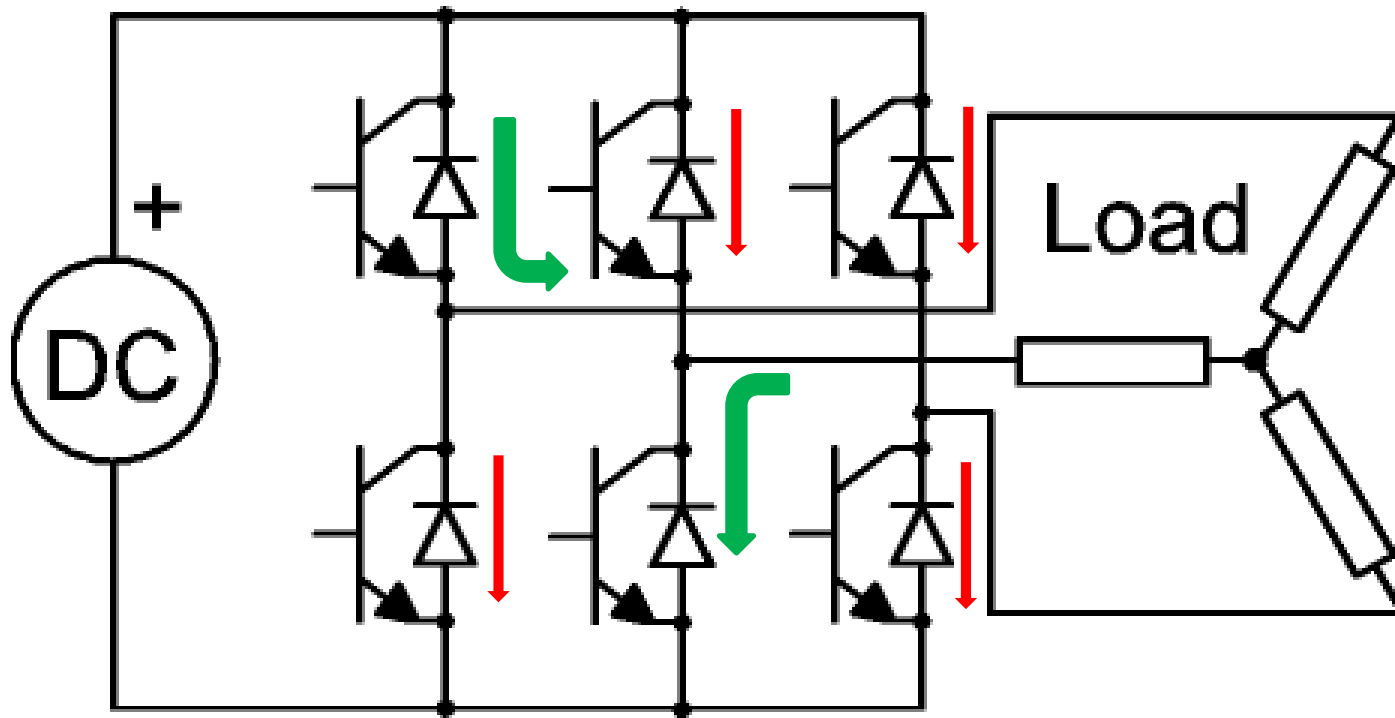
# Possible impact on inverter performance



- OFF-state leakage current may result in loss of power delivered to load
- Need to evaluate devices at much higher  $V_{CE}$
- Planning SPICE modeling to determine impact on inverter efficiency



# Same concept applies to three-phase inverter



# IGBT monitoring inside inverter

- Plan is to monitor IGBT properties inside working inverter to compare degradation to device-level testing
- Several inverters have been purchased, currently setting up (planning to use solar simulator as DC source)

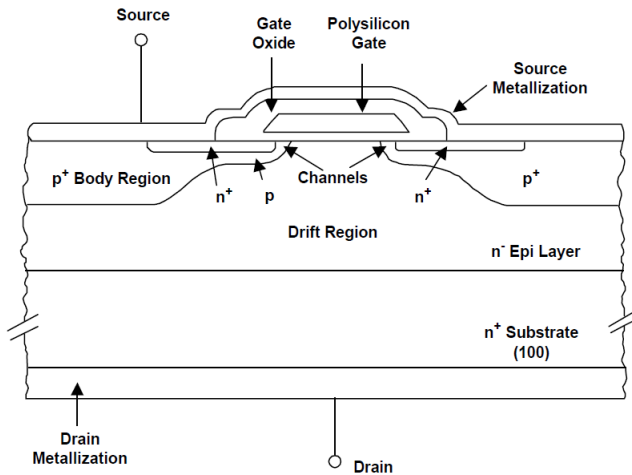


# “Post-Silicon” device reliability for power electronics

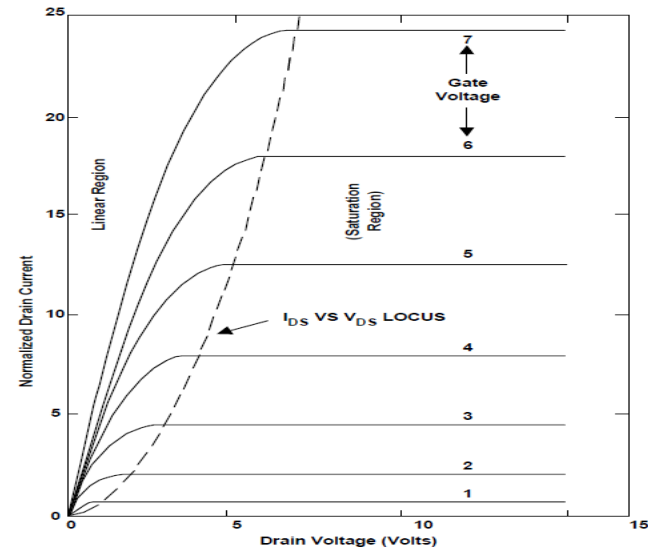


- Record-efficiency inverter has been demonstrated using SiC MOSFETs
- We have done reliability testing on the same MOSFET used in the inverter

# SiC power MOSFET

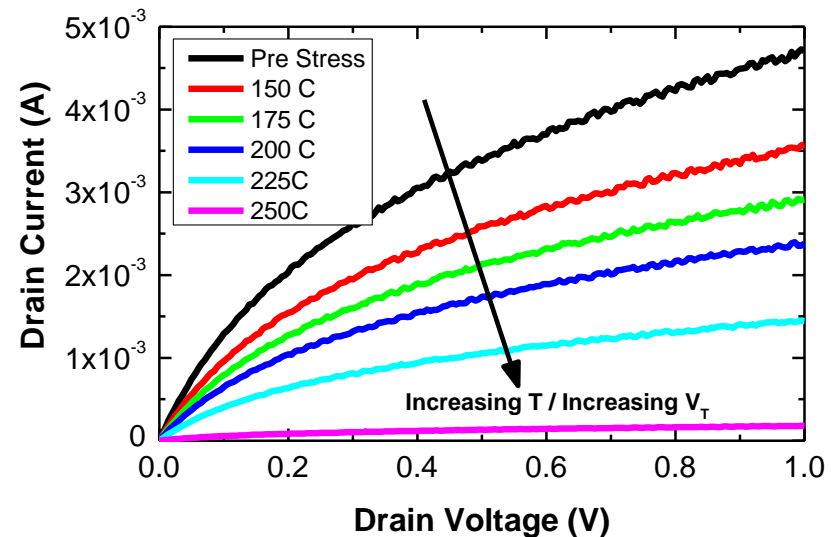
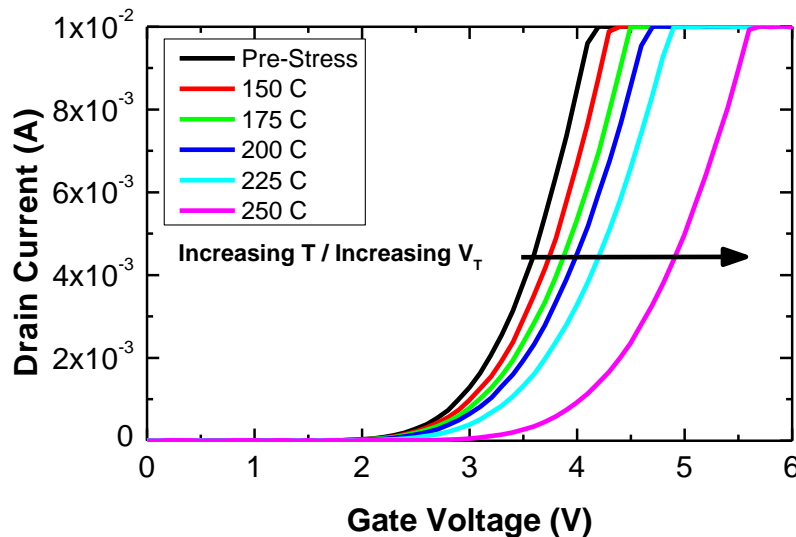


Drawings from International Rectifier,  
“Power MOSFET Basics”



- SiC has many intrinsic material advantages over Si for power devices
  - Large bandgap (low intrinsic carrier concentration at high T)
  - High breakdown field strength (avalanche breakdown)
  - High thermal conductivity
- But it is a much less mature technology and is thus less reliable
  - SiO<sub>2</sub> gate oxide reliability
  - SiC material defects ( $\mu$ -pipes), stacking faults

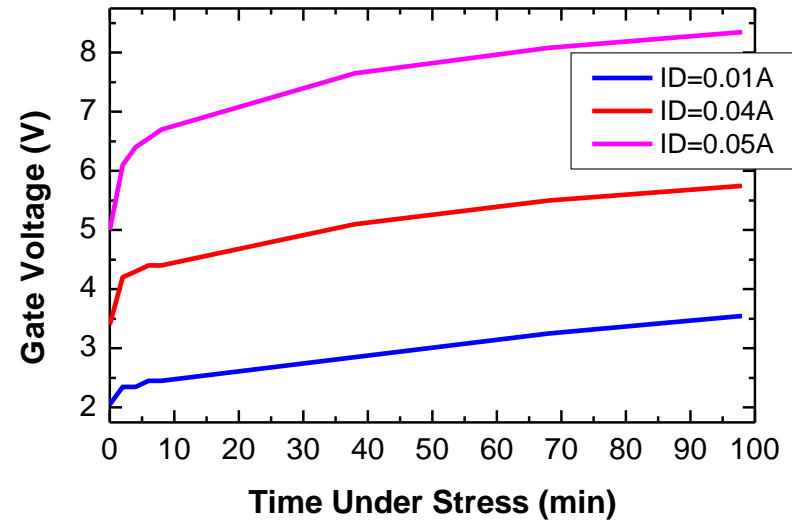
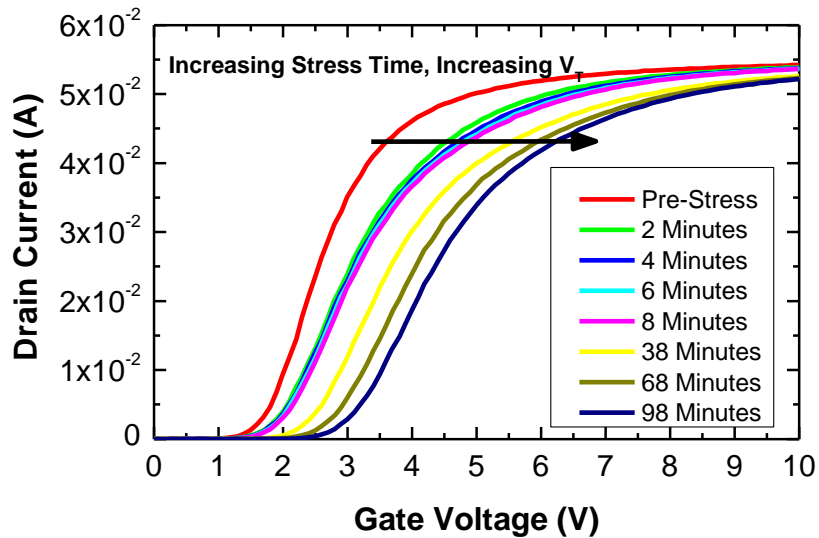
# n-channel SiC MOSFET BTS experiment #1



- Measured  $I_D$ - $V_G$  ( $V_D = +1$  V) and  $I_D$ - $V_D$  ( $V_G = +4$  V) curves at room T
- Heated sample to temperature indicated and applied +20 V gate voltage for 7 minutes
- Cooled back to room temperature and  $I_D$ - $V_G$ ,  $I_D$ - $V_D$  curves were re-measured
- Process was repeated for various stress temperatures
- Positive  $V_T$  shift suggests presence of negative charge in oxide, perhaps injected from n-channel during stress
- Decrease in current for fixed bias degrades ON-state performance of device



# n-channel SiC MOSFET BTS experiment #2



- Sample heated to 225°C and  $I_D$ - $V_G$  curve measured ( $V_D = +1$  V)
- Gate stress of +20 V applied for time indicated
- $I_D$ - $V_G$  curve re-measured at 225°C
- Process was repeated for various additional stress times
- Increase in  $V_T$  is again observed and will degrade ON-state performance of switch, resulting in less power delivered to load



# Continuing work

- Stressing of Si-based IGBTs under various conditions
  - High current, high voltage, transient high power
- Monitoring of IGBTs in actual inverters and comparison to device-level testing
- Modeling of device lifetime and failure mechanisms for inclusion in inverter and system reliability models
- “Post-Si” device studies (SiC, GaN) for future power electronics needs
  - Basic defect studies and reliability physics
  - Device modeling
- Stress testing of electrolytic bus capacitors
- **Goal is to establish unbiased, standardized test procedures and reliability / efficiency models for industry**